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Applicant: Toshifumi SUGANAGA Docket No. 57454-025

Title/Mark: EXPOSURE APPARATUS, EXPOSURE METHOD AND SEMICONDUCTOR

Date Sent: 3/30/01 ☒ Hand Carried ☐ Fax ☐ 1st-Class Mail ☐ Cert. of Mailing ☐ Express Mail No. _____

☒ Transmittal Letter

☒ New Patent App ☒ Utility ☐ Design ☐ Cont. ☐ CIP ☐ Div. ☐ PCT ☐ CPA ☐ RCE ☐ Prov

Other: _____

☒ 14 _____ pages of Specification

☒ 4 _____ pages of Claims

☒ 1 _____ pages of Abstract

☒ 8 _____ pages of Formal/Informal Drawings

☒ Information Disclosure Statement

1 _____ Form PTO 1449

2 _____ copies of cited references

☐ Preliminary Amendment

☐ Response to Missing Parts Notice

☒ Certified Copy of Priority Doc

☒ Claim for Convention Priority

☐ Verified Statement of Small Entity Status

☐ Transmittal of Issue Fee: _____ Form PTO 85b

☐ Maintenance Fee for _____ years after grant

☐ Notice of Appeal ☐ Appeal Brief

☒ Recordation of 1 Patent _____ Trademark:

☐ Response/Amendment to Office Action of _____

☐ Other _____

Assignments/Security Agreements/ _____ Petition to Commissioner for _____

☐ Trademark/Service Mark/Intent-To-Use Application

☐ Amendment to Allege Use

☐ Formal/Informal/Substitute Drawing Sheet

_____ (no. of) Substitute/Specimens

☐ Continued Use Affidavit/Declaration (Section 8 & 15)

☐ Notice of Opposition/Answer to

☐ Ex Parte Appeal

☐ Petition for Cancellation/Answer To

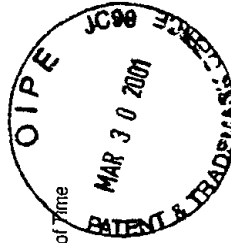
☐ Renewal of Reg. No.

☒ Combined Declaration/Power of Attorney

☐ Letter of Protest

☐ Request for _____-day/month Extension of Time

☐ Request for Non-Publication



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THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.								

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

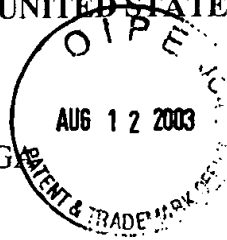
In re Application of

Toshifumi SUGANAGA

Serial No.:

Filed: March 30, 2001

For: EXPOSURE APPARATUS, EXPOSURE METHOD AND SEMICONDUCTOR DEVICE
FABRICATED WITH THE EXPOSURE METHOD



Group Art Unit:

Examiner:

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

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Dear Sir:

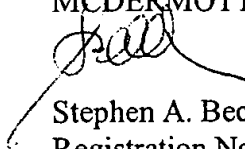
In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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